

INFORMATION DISCLOSURE STATEMENT

Applicant : Yamazaki et al.

App. No : 10/566,425

Filed : January 30, 2006

For : POSITIVE RESIST COMPOSITION
AND METHOD OF FORMING
RESIST PATTERN

Examiner : Geraldina Visconti

Art Unit : 1752

**CERTIFICATE OF EFS WEB
TRANSMISSION**

I hereby certify that this correspondence, and
any other attachment noted on the automated
Acknowledgement Receipt, is being transmitted
from within the Pacific Time zone to the
Commissioner for Patents via the EFS Web
server on:

January 25, 2008

(Date)


Neil S. Bartfeld, Reg. No. 39,901

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 10 references to be considered by the Examiner. Also enclosed are 3 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 1/25/08

By:


Neil S. Bartfeld, Ph.D.
Registration No. 39,901
Agent of Record
Customer No. 20,995
(619) 235-8550